



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Yi-Ming Sheu

Serial No.:10/619,114

Filed: 07/14/2003

For: NARROW WIDTH EFFECT
IMPROVEMENT WITH PHOTORESIST PLUG
PROCESS AND STI CORNER ION
IMPLANTATION

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)
) Group Art Unit: 2823

)
) Examiner: Brewster, William

)
) Confirmation No.: 6852

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) TKHR Docket: 252016-1300
) Top-Team Dkt: 0503-9540US
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Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on February 25, 2005.


Signature - Hui Chin Barnhill

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed December 23, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

Do not Enter
JWB
15 MAR 05